



PATENT
Atty. Dkt. AMAT/7773/CMP/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Chen, et al.

Serial No.: 10/678,906

Confirmation No.: Unknown

Filed: October 3, 2003

For: Methods for Reducing Delamination During Chemical Mechanical Polishing

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: Unknown

Examiner: Unknown

CERTIFICATE OF MAILING
37 CFR 1.8

INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.



The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

If the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No.20-0782/AMAT/7773/BKH.

Respectfully submitted,

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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)					Docket No. AMAT/7773/CMP/ CMP/RKK		Serial No. 10/678,906	
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT (Use several sheets if necessary)					Applicant Chen, et al.		Confirmation No.: Unknown	
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							YES	NO
	B1	1 116 762	07/18/2001	EP	C09G	01/02	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B2	1 093 161	04/18/2001	EP	H01L	21/768	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B3	1 125 999	08/22/2001	EP	C09G	01/02	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B4	1 104 020	05/30/2001	EP	H01L	21/768	<input type="checkbox"/>	<input checked="" type="checkbox"/>
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	C1	United States Patent Application 09/569,968 filed on 05/11/2000 (AMAT/4534)						
	C2							
Examiner					Date Considered			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

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	B8	1 603 558	06/11/1971	FR	C23G	01/00	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B9	2001-139937	05/22/2001	JP	C09K	03/14	<input type="checkbox"/>	<input checked="" type="checkbox"/>
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	B14	00/35627	06/22/2000	WO	B24B	37/04	<input type="checkbox"/>	<input checked="" type="checkbox"/>
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	B16	00/00561	01/06/2000	WO	C09G	01/02	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B17	98/41671	09/24/1998	WO	C23F	01/14	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B18	98/49723	11/05/1998	WO	H01L	21/321	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B19	98/04646	02/05/1998	WO	C09K	13/00	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B20	98/44061	08/10/1998	WO	C09G	01/02	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B21	98/36045	08/20/1998	WO	C11D	03/18	<input type="checkbox"/>	<input checked="" type="checkbox"/>
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	C5							
	C6							
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